



00862.022168

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Seiji TAKEUCHI et al. ) : Examiner: A. Kosowski  
Application No.: 09/819,670 ) : Group Art Unit: 2125  
Filed: March 29, 2001 ) : Confirmation No.: 3161  
For: STOCKER, EXPOSURE APPARATUS, ) : January 29, 2004  
DEVICE MANUFACTURING METHOD, ) :  
SEMICONDUCTOR MANUFACTURING )  
FACTORY, AND EXPOSURE APPARATUS :  
MAINTENANCE METHOD )

15/D  
C.A.  
2/4/04

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Technology Center 2100

AMENDMENT

Sir:

In response to the Official Action dated October 29, 2003, please amend the above-identified application as follows: